



IPW

Docket No. EATNP148US

03-IMP-001

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re **PATENT** application of:

Applicant: Peter Kellerman et al.

Application No.: 10/657,449

For: CLAMPING AND DE-CLAMPING SEMICONDUCTOR WAFERS
ON AN ELECTROSTATIC CHUCK USING WAFER INERTIAL
CONFINEMENT BY APPLYING A SINGLE-PHASE SQUARE
WAVE AC CLAMPING VOLTAGE

Filing Date: September 8, 2003

Examiner: Boris Benenson

Art Unit: 2836

REPLY TO OFFICE ACTION DATED AUGUST 11, 2004

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Favorable reconsideration of the above-identified application is respectfully
requested in view of the following remarks.